



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	Attorney Docket No. 2003_1364A
Takashi OHSAKO et al.	:	Confirmation No. 8585
Serial No. 10/677,221	:	Group Art Unit 2895
Filed October 3, 2003	:	Examiner Joannie A. Garcia
METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT	:	Mail Stop: AMENDMENT

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 11, 2009, a Petition for a two month extension of time being submitted herewith, please amend the above-identified application as follows.